REGISTRATION FORM

Final Report Meeting of MEXT Project:

Research and Development of Spintronics Material and Device Science and Technology for a Disaster-Resistant Safe and Secure Society

February 22, 2017

-	Middle Name	First Name	•
性	名	• For Japa	の方は氏名欄に日本語(漢字) でもご記入下さい。 nese registrants: ease fill in your name here, too.
□ Prof. □ Dr. □ Mr. □ Ms.			
Title		_	
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Company/ University			
Address			
State/Country	E-mail Address		
	t through this form will be used in such cas	es as the following:	

• The meeting is free of charge, but registration is required.

Yes

No

Will you attend the Banquet?

• The Banquet fee payment will be made in cash (JPY) on site at the registration desk.

E-Mail this form to CSIS Support Office: csis2017@riec.tohoku.ac.jp

